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3724

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#4

In re the application of:

Xuyen PHAM

Application No. 10/029,457

Filed: December 21, 2001

For: POROUS MATERIAL AIR BEARING  
PLATEN FOR CHEMICAL  
MECHANICAL PLANARIZATION

Group Art Unit: 2812

Examiner: Not Assigned

Atty. Docket No. LAM2P310

Date: July 24, 2003

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on July 24, 2003.

Signed:

Diane Schwanbeck

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR §§1.56 AND 1.97(c)

Commissioner for Patents  
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicant submits these references in compliance with his duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to consider these references and to acknowledge such consideration by initialing the appropriate locations on the attached PTO Form 1449.

This Information Disclosure Statement (IDS) is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This IDS is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this IDS. However, if it is determined that any fees are due, then the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0805 (Order No. LAM2P310).

Respectfully submitted,  
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Attorney Docket No. LAM2P310

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<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Atty Docket No. LAM2P310	U.S. 10/029,457
	Applicant: Xuyen Pham	
	Filing Date: December 21, 2001	Group: 2812

### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class
	A	5,558,568	9/1996	Talieh et al.	451	303
	B	5,593,344	1/1997	Weldon et al.	451	296
	C	5,692,947	12/1997	Talieh et al.	451	41
	D	5,722,877	3/1998	Meyer et al.	451	41
	E	5,800,248	9/1998	Pant et al.	451	41
	F	5,916,012	6/1999	Pant et al.	451	41
	G	5,961,372	10/1999	Shendon	451	41
	H	5,980,368	11/1999	Chang et al.	451	303
	I	6,086,456	7/2000	Weldon et al.	451	41
	J	6,155,915	12/2000	Raeder	451	285
	K	6,358,118	3/2002	Boehm et al.	451	24

### Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	L	EP 0 706 857 A	4/1996	EPO	B24B	37/04		
	M	EP 0 914 906 A2/3	5/1999	EPO	B24B	37/04		
	N	WO 00 25982 A	5/2000	WIPO	B24B	37/04		
	O							
	P							

### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	R	
	S	
	T	
Examiner		Date Considered

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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered.  
 Include copy of this form with next communication to applicant.